

# Photo-injector, General Plan & Photocathodes

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## 1. The CTF3 photo-injector

## 2. Status of the project

↪ Laser (see M. Divall's presentation)

↪ RF gun (see R. Roux's presentation)

↪ Photocathodes

↪ Installation

## ↪ Photocathode studies

## ↪ Schedule

# CTF3 Photo-injector specifications

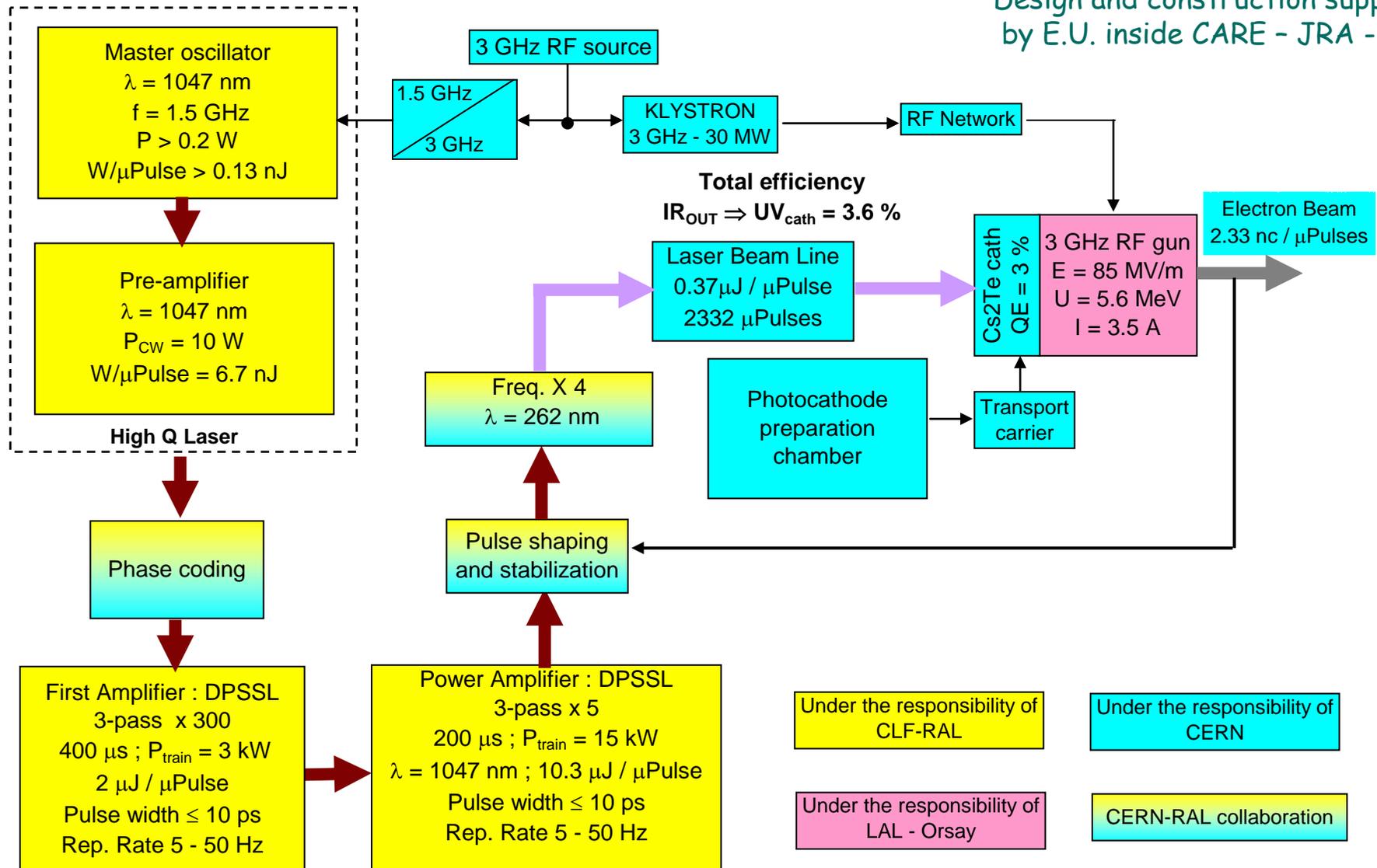
Pulse train duration (1)	1.548	$\mu\text{s}$
Pulse train charge (1)	5434	nC
Average current in the pulse train	3.51	A
Number of bunches in the sub-pulse	212	
Odd/even sub-pulse width (FWHH)	140.735	ns
Number of bunches in the pulse train (1-2)	2332	
Charge / bunch	2.33	nC
Distance between bunches	0.667	ns
Bunch width (FWHH)	10	ps
$\varepsilon_T$ normalized (rms) $\leq$	25	$\pi.\text{mm.mrad}$
$\Delta p/p$ (rms) $\leq$	2	%
charge stability $\leq$	0.25	%
Repetition rate	1 - 50	Hz
Mean current @ 50 Hz	271.68	mA

(1) With starting bunches

(2) The photo-injector must be able to produce only one electron pulse

# The CTF3 Photo-injector synoptic

Design and construction supported by E.U. inside CARE - JRA - PHIN



# Laser: Oscillator & preamplifier

- ↪ 1.5 GHz, 10 ps pulse width, temporal jitter < 1 ps rms + 10 W CW preamplifier
- ↪ Estimated cost : 200 kCHF + 100 kCHF

## Firms invited to tender

Supplier name	Origin	Contacted On	Town	Country	Response
HIGHLASER PRODUCTION GMBH	I1	10/06/2004	HOHENEMS	AT	INTEREST
TBWP (TIME-BANDWIDTH PRODUCTS)	I1	10/06/2004	ZURICH	CH	INTEREST
ALPHALAS GMBH	I1	10/06/2004	GOETTINGEN	DE	NOREPLY
JENOPTIK GMBH	I1	10/06/2004	JENA	DE	NOREPLY
LUMERA LASER GMBH	I1	10/06/2004	KAISERSLAUTRN	DE	NOREPLY
MAX-BORN-INSTITUTE (MBI)	I1	10/06/2004	BERLIN	DE	NOREPLY
SPECTRA-PHYSICS GMBH	I1	10/06/2004	DARMSTADT	DE	NOREPLY
COHERENT SCIENTIFIQUE	I1	10/06/2004	ORSAY CEDEX	FR	NOREPLY
ADVANCED OPTICAL TECHNOLOGY LTD	X1	16/06/2004	BASILDON ESSEX	GB	NOREPLY
LASER LINES (INDUSTRIAL & MEDICAL) LTD	I1	10/06/2004	OXON	GB	NOREPLY
UNIVERSITY OF STRATHCLYDE	I1	10/06/2004	GLASGOW	GB	DECLINED

**High Q Laser production: oscillator + preamplifier in a same enclosure**  
**~ 269 kCHF , delivery is foreseen end of February**

# Laser: Pumping diodes

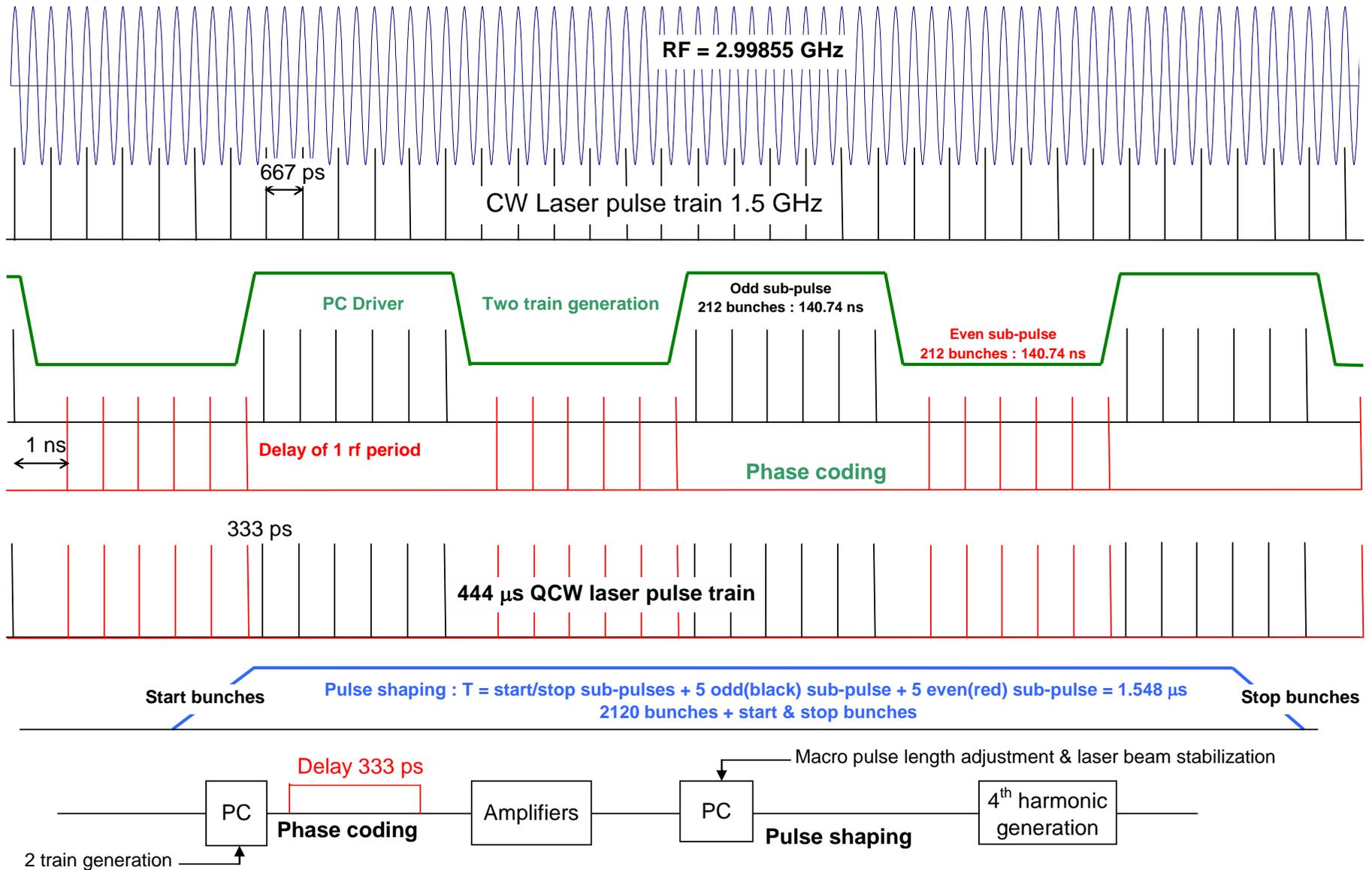
## First amplifier

- ↪ 18 kW total peak power at 2.5 % duty cycle, 50 Hz rep. rate  
Using a 7 cm long, 0.7 cm diameter Nd:YLF rod
- ↪ Estimated cost: 180 kCHF ; expected delivery: April - May 2005

**Firms invited to tender** (price enquiry DO-21929/ AB)

Supplier name	Origin	Contacted On	Town	Country	Response
DILAS DIODENLASER Gmbh	II	17/11/2004	MAINZ	DE	
JENOPTIK Gmbh	II	17/11/2004	JENA	DE	
LASER ENGINEERING APPLICATION S.A.	II	17/11/2004	ANGLEUR	BE	
ROITHNER LASERTECHNIK	II	17/11/2004	VIENNA	AT	
THALES LASER DIODES	II	17/11/2004	ORSAY	FR	

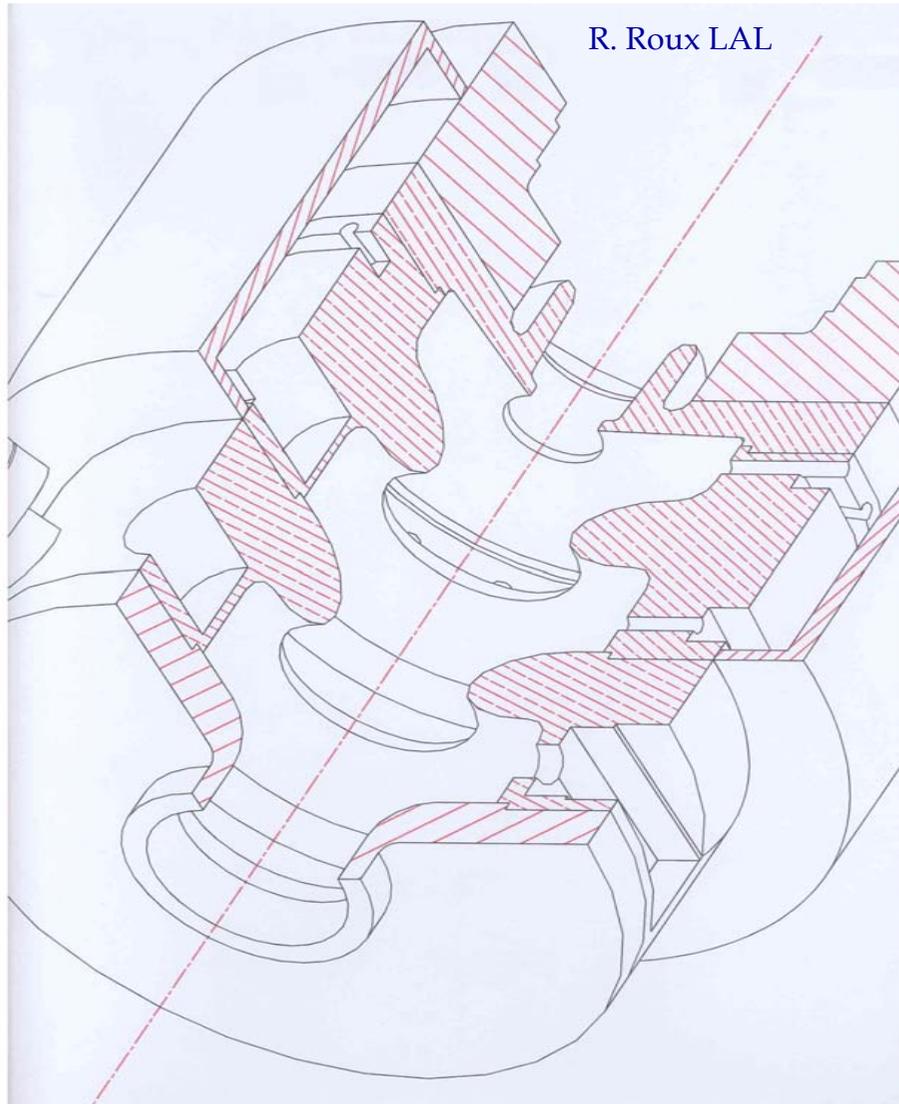
# Phase coding and pulse shaping (1)



# Phase coding and pulse shaping (2)

- ↪ RF for laser mode-locking : 3 dBm @ 1.49928 GHz
- ↪ 3 programmable timing pulses with a ps jitter
- ↪ 4 programmable standard timing pulses
- ↪ Fast Pockels cell drivers with rise and fall time < 500 ps (10%-90 %)
- ↪ Pattern generator with jitter < 10 ps rms

# RF gun

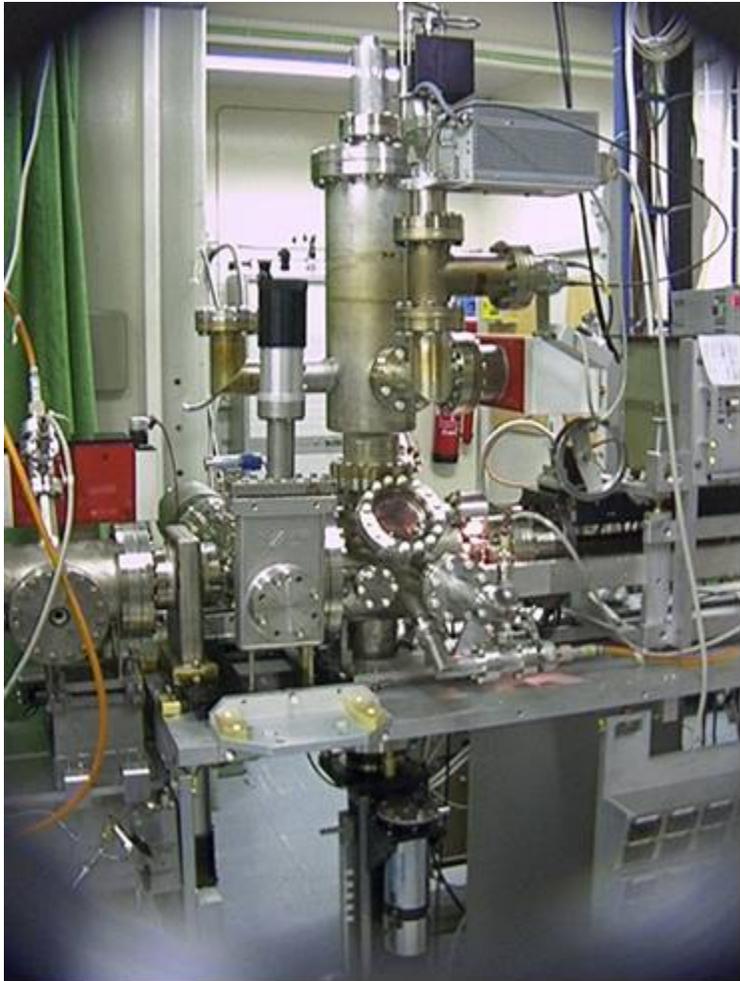


<b>RF frequency (GHZ)</b>	<b>2.99855</b>
<b>RF power (MW)</b>	<b>30</b>
<b>Acc. electric field (MV/m)</b>	<b>85</b>
<b>Beam energy (MeV)</b>	<b>5.6</b>
<b>Beam current (A)</b>	<b>3.5 - 5</b>
<b>Charge/bunch (nC)</b>	<b>2.33</b>
<b>Bunch length (ps)</b>	<b>10</b>
<b>Energy spread (%)</b>	<b>&lt; 2</b>
<b>Normalized emittance (<math>\pi</math>.mm.mrad)</b>	<b>&lt; 25</b>
<b>Number of pulses</b>	<b>~ 2332</b>
<b>Pulse train duration (<math>\mu</math>s)</b>	<b>1.548</b>
<b>Coupling factor (<math>\beta</math>)</b>	<b>2.9</b>
<b>Vacuum pressure (mbar)</b>	<b><math>2.10^{-10}</math></b>
<b>Repetition rate (Hz)</b>	<b>50</b>

# Photocathodes for the CTF3 photo-injector

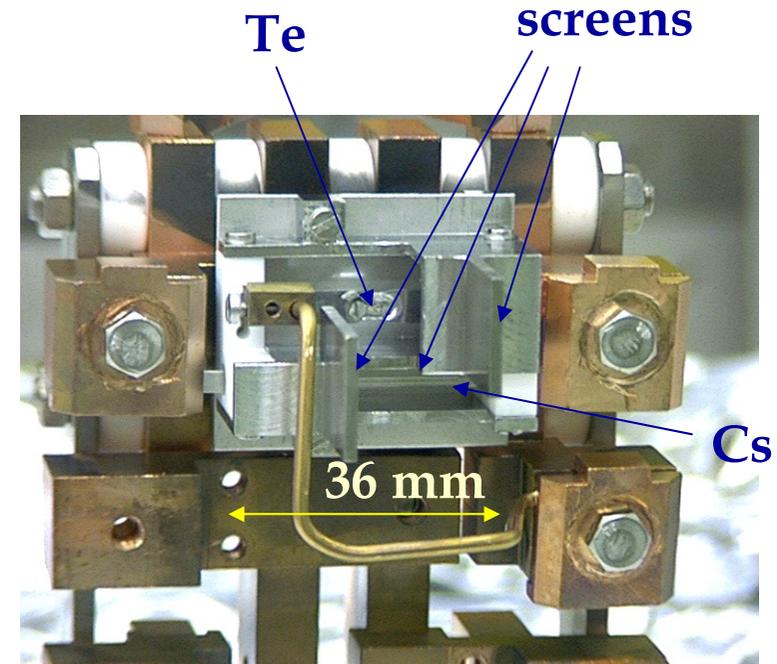
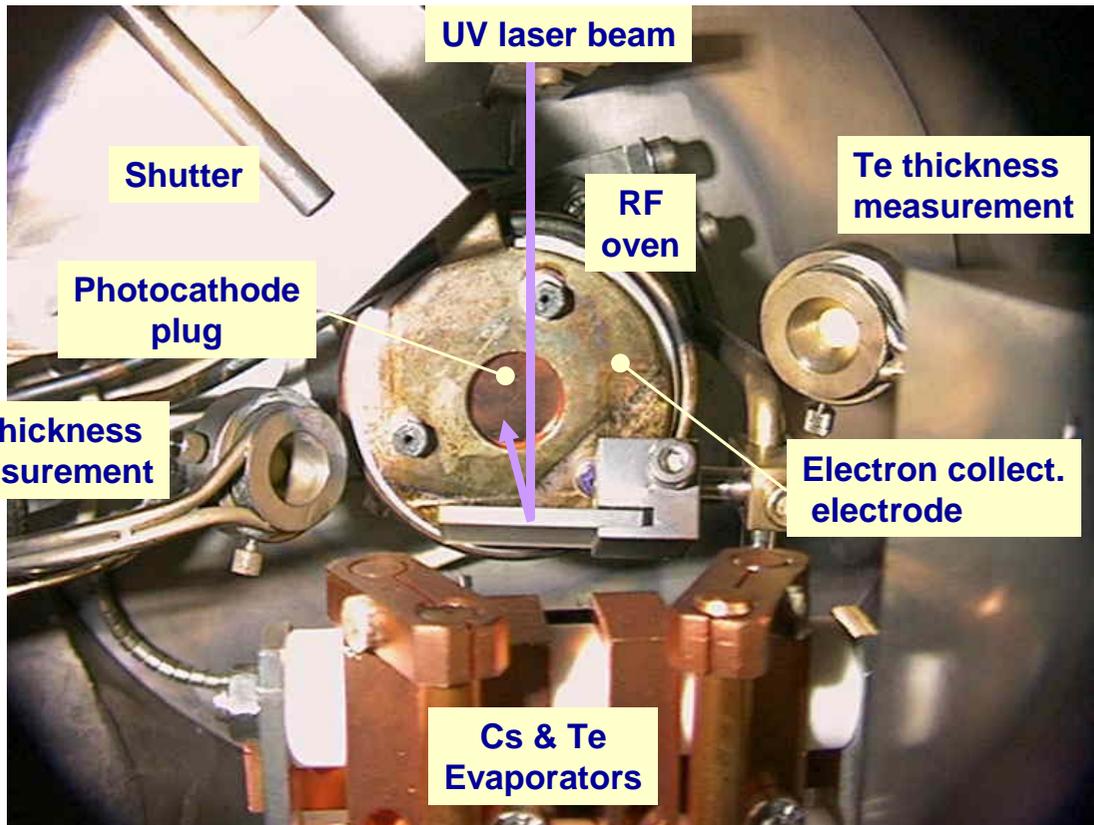
**Photocathodes with a QE  $\geq 3$  % during at least 40 working hours**

**A photocathode production to guarantee a continuous run of at least 6 months**



- ↪ **The rejuvenation of the preparation chamber is completed**
- ↪ **A new port has been added to allow cathode transfer for analysis without breaking the vacuum (AUGER and XPS analysis)**
- ↪ **Design of a small transport chamber between preparation chamber and XPS analysis bench compatible with the CEA- SP2A's chamber**
- ↪ **A new mass spectrometer with mass up to 200 has been installed**
- ↪ **A new bake-out installation, clean-room compatible, was designed and ordered. Installation expected for the end of November.**

# Photocathode production by co-evaporation



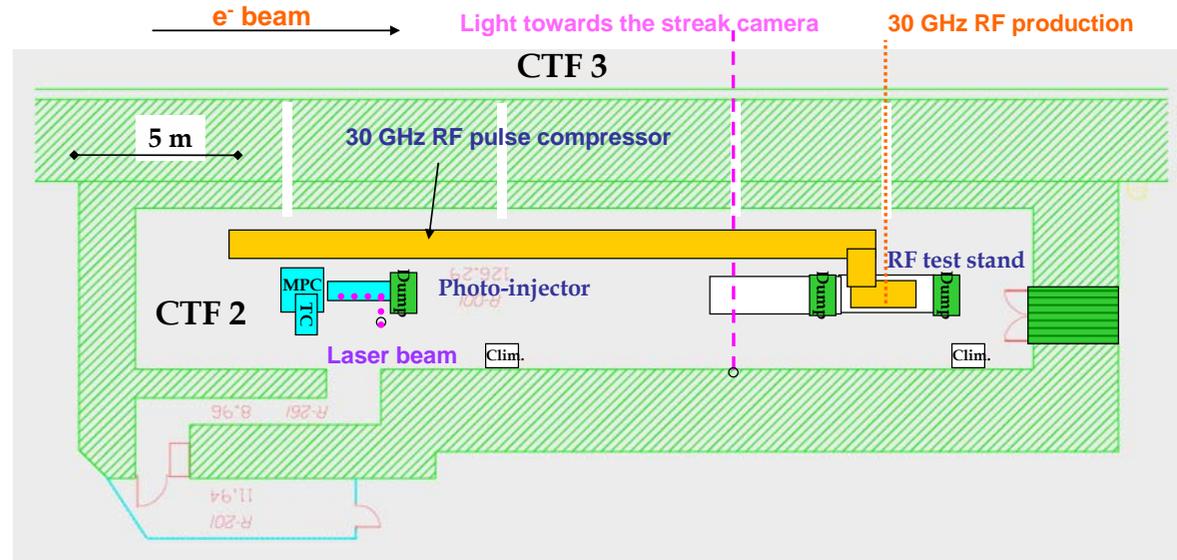
Preparation chamber ready to start studies of:

- ↪ New evaporators
- ↪ Evaporation of alkali-antimonides

# Photo-Injector installation

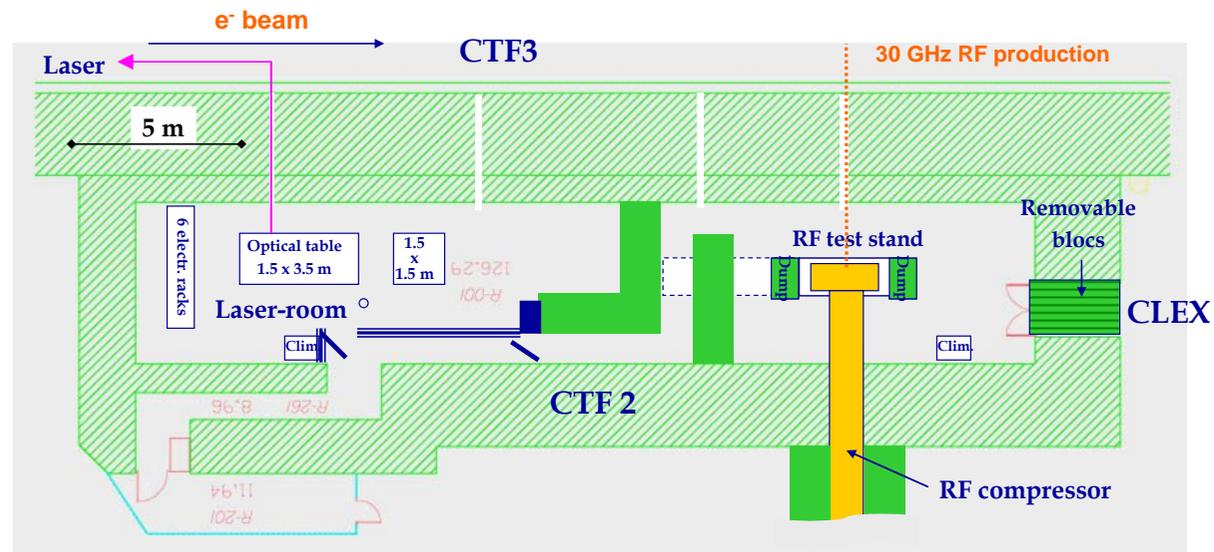
## 2004 - end of 2006

- ★ Photo-injector in the former CTF2
- ★ Laser-room in the former CTF2 laser-room
- ➔ Position stability not guaranty



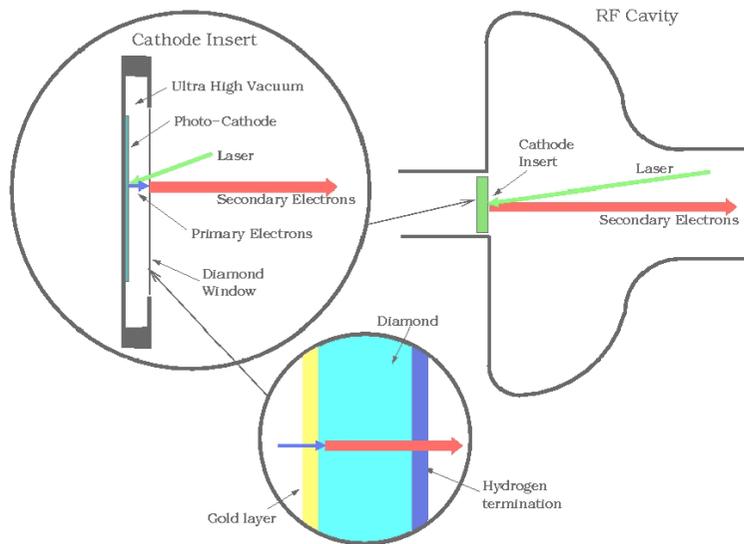
## From 2007

- ★ Photo-injector in the place of the CTF3 thermionic gun
- ★ Laser-room in the first part of the CTF2



## Secondary Emission Enhanced photo-emitter

Proposal from I. Ben-Zvi et al. C-A/AP#149, April 2004, BNL



### Expected advantages

- ◆ Very high equivalent QE ~ 1000 % !
- ◆ Low laser power
- ◆ Low thermal emittance (NEA surface)
- ◆ No mutual contamination between the gun and the photocathode
- ◆ Possible high mean current
- ◆ No load-lock system

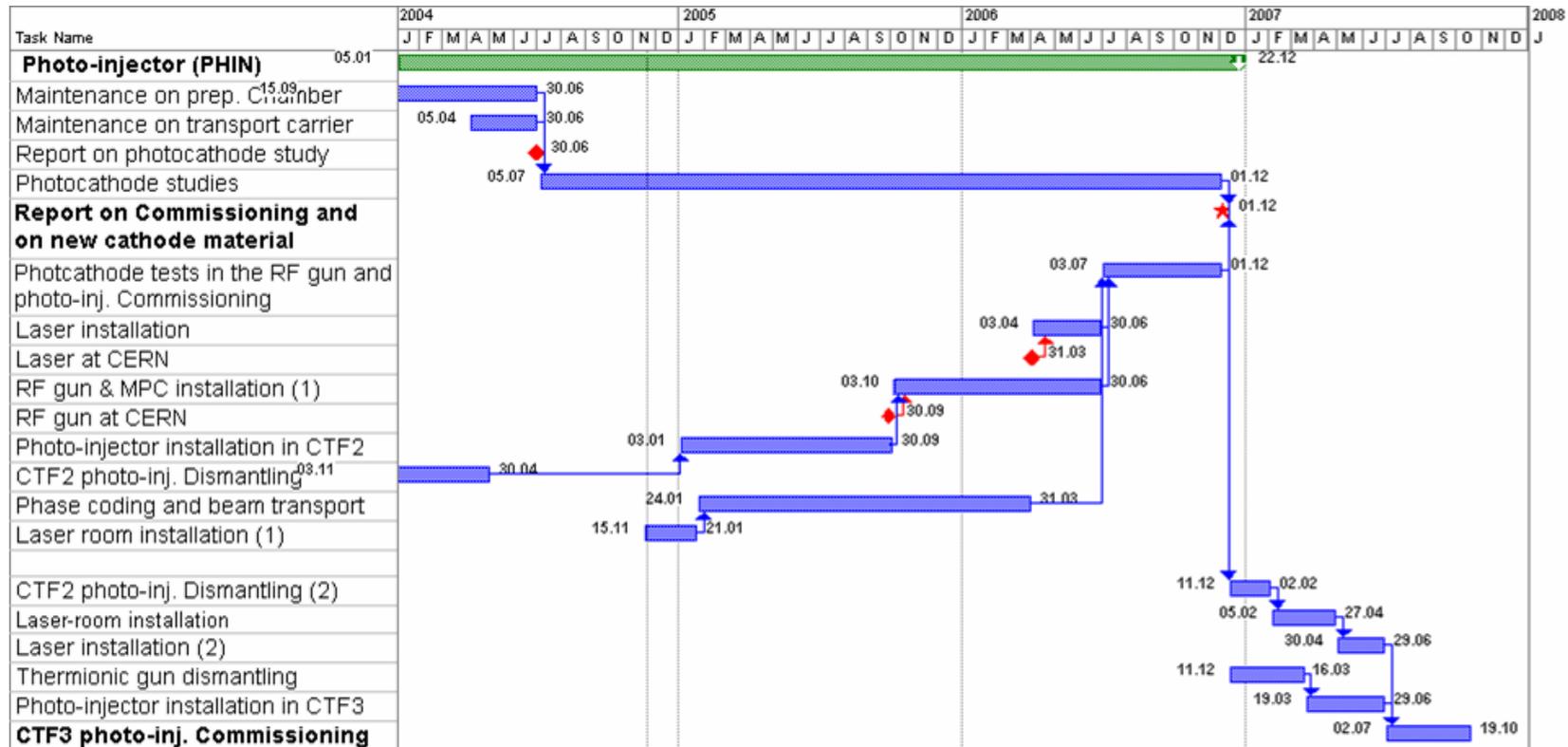
- Cathode insert consist of :
- Alkali antimonide cathode
- A sealed diamond window (~10  $\mu\text{m}$  thick)
- UHV in between

- The diamond window is transparent to photons and electrons
- Electrons are produced by a laser beam shooting an alkaline cathode
- Electrons are multiplied by secondary emission by the diamond window

# Schedule

## Realization of the photo-injector option in two steps :

### ↳ Photo-injector commissioning in the CTF2: summer 2006



### ↳ Operational photo-injector in the CTF3 in 2007

- Installation during the shut-down 2006-2007
- Commissioning from summer 2007